# Atomistic Engineering of Catalyst Precursors -Dynamic Reordering of PdAu Nanoparticles during Vinyl Acetate Synthesis enhanced by Potassium Acetate

Elisabeth K. Hanrieder, Andreas Jentys and Johannes A. Lercher\*

Department of Chemistry and Catalysis Research Center, Technische Universität München,

Lichtenbergstr. 4, 85747 Garching, Germany

\*E-Mail: johannes.lercher@mytum.de

# **Transmission Electron Microscopy**

TEM images were collected on a *JEM-2010-JEOL* microscope applying an acceleration voltage of 120 kV to electrons generated by a  $LaB_6$  source. The resolution of the microscope is 0.2 nm. Before measurement the samples were dispersed in ethanol and dropped on a copper-grid supported film.

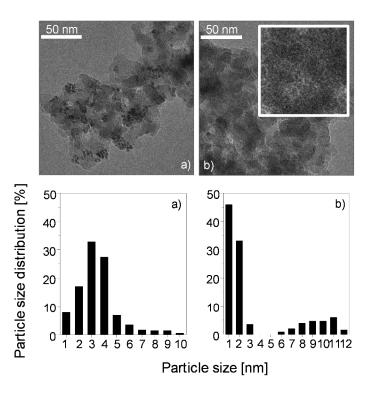


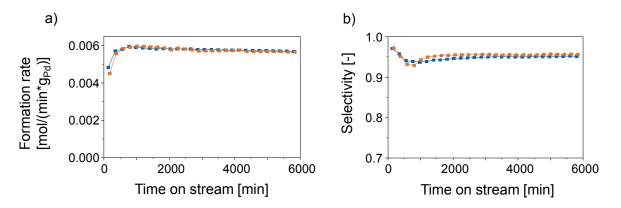
Figure S1 TEM images and particle size distribution of (a) fresh and (b) used (Pd+Au)/KOAc/SiO<sub>2</sub>.

The particle size distribution of fresh (Pd+Au)/KOAc/SiO<sub>2</sub> (Figure S1a) revealed an average particle size of ~3.5 nm. After reaction (Figure S1b), small particles in the range of 1-2 nm were found together with bigger agglomerates in the range of ~5 to 12 nm. The small particles are associated with leached and reduced  $Pd^0$  clusters whereas the bigger particles are Au rich as indicated by XRD. A number of the large metal particles was encased within a low contrast shell, most likely consisting of acetate deposits.<sup>1</sup>

#### Catalytic Result of (Pd+Au)/KOAc/SiO<sub>2</sub>

The catalytic activity normalized to the total concentration of Pd and the selectivity of PdAu/KOAc/SiO<sub>2</sub> and (Pd+Au)/KOAc/SiO<sub>2</sub> (Figure S2) are almost identical. The overall activity contains contributions of the activity of Pd in PdAu and from Pd<sup>2+</sup>, which is about 20% less active than Pd in PdAu. (Pd+Au)/KOAc/SiO<sub>2</sub> contains 91% dispersed Pd whereas PdAu/KOAc/SiO<sub>2</sub> contains only 53%. Therefore, for (Pd+Au)/KOAc/SiO<sub>2</sub> dispersed Pd

contributes more to the overall activity than on PdAu/KOAc/SiO<sub>2</sub>. On the other hand, the Au enriched PdAu particle surface (molar Pd/Au ratio on the surface of 1.1) on (Pd+Au)/KOAc/SiO<sub>2</sub> contributes less to the overall activity compared to PdAu/KOAc/SiO<sub>2</sub> (molar Pd/Au ratio on the surface of 2.0) both effects compensate and lead to the similar activity observed.



**Figure S2.** (a) Formation rates normalized to the total concentration of Pd and (b) selectivities for PdAu/KOAc/SiO<sub>2</sub> (blue) and (Pd+Au)/KOAc/SiO<sub>2</sub> (orange) with time on stream. Reaction conditions: 60 vol %  $C_2H_4$ , 13 vol % AcOH, 4.5 vol %  $O_2$ , balance  $N_2$ ; total pressure, 8.8 bar; temperature, 150 °C.

## IR Spectroscopy of Adsorbed CO on Silica

At -150 °C, 1.0 mbar CO adsorbed on the silica support (Figure S3) by interacting with cations (2184 cm<sup>-1</sup>) and with the OH groups on silica (2157 cm<sup>-1</sup>).<sup>2-3</sup> Physically adsorbed CO appeared at 2135 cm<sup>-1</sup>.<sup>4</sup> The normalized absorbance ( $10^{-5}$ ) is about one order of magnitude lower than the absorbance on fresh and reacted samples ( $10^{-4}$ ).

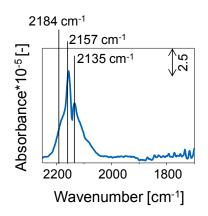


Figure S3. IR spectrum of 1.0 mbar CO adsorbed on  $SiO_2$  at -150 °C.

### Calculation of the Absorption Coefficients $\epsilon$ of CO on Au and Pd

*Lambert-Beer law:*  $A = \varepsilon \cdot c \cdot d A = \varepsilon \cdot c \cdot d$ 

A = Absorbance (height) or integrated area  $[cm^{-1}]$ 

 $\varepsilon$  = Absorption coefficient [cm<sup>2</sup> mol<sup>-1</sup>] (if IR band intensity is used) or [cm mol<sup>-1</sup>] (if IR band area [cm<sup>-1</sup>] is used)

c = Concentration of the absorbing substance [mol l<sup>-1</sup>]

d = Thickness [cm]

with  $\mathbf{c} \cdot \mathbf{d} = \frac{\mathbf{n}_{S}}{s} = \text{const.}$ 

 $n_{S}$  = Number of total Au or Pd surface atoms [mol]

S = Surface of the wafer; S =  $r^2 \cdot \pi$ , r = radius of the wafer [0.6 cm]

$$A = \varepsilon \cdot \frac{n_S}{S}$$

$$\varepsilon = A \cdot \frac{S}{n_S}$$

$$\varepsilon = A \cdot \frac{r^2 \cdot \pi}{n_S}$$
$$\varepsilon = A \cdot \frac{r^2 \cdot \pi}{\frac{n_S}{g_{SIO2}} \cdot m_W}$$

 $m_W = mass of the wafer [g]$ 

 $n_{S} =$  Number of total Au or Pd surface atoms;  $n_{Au} = \frac{\frac{m_{Au}}{g_{SiO2}}}{M_{Au}} D$   $n_{Pd} = \frac{\frac{m_{Pd}}{g_{SiO2}}}{M_{Pd}} D$ 

 $\frac{m_{Au}}{m_{SiO2}}$  Concentration of Au on SiO<sub>2</sub> [g/g];  $\frac{m_{Pd}}{m_{SiO2}}$  Concentration of Pd on SiO<sub>2</sub> [g/g]

 $M_{Au} = 197 \text{ g/mol}; \qquad M_{Pd} = 106.4 \text{ g/mol}$ 

D = dispersion  $(D = \frac{n_s}{n_{total}})$  (Dispersion derived from average particle size in TEM)

Calculation of the extinction coefficients of CO on Au ( $\varepsilon_{l,Au}$ )

$$\varepsilon_{l,Au} = \frac{\frac{6.28 \text{ cm}^{-1} \cdot (0.6 \text{ cm})^2 \cdot \pi}{\frac{0.024 \text{ g}_{Au}}{g_{SiO2}}}{\frac{g_{SiO2}}{197 \frac{g}{\text{mol}}} \cdot 0.26 \cdot 0.01606 \text{ g}}$$

 $\epsilon_{l,Au} = 1.40 \cdot 10^7 \text{ cm mol}^{-1}$ 

Calculation of the extinction coefficients of CO on Pd ( $\varepsilon_{l,Pd}$ ,  $\varepsilon_{b,Pd}$ )

$$\varepsilon_{Pd} = \frac{\frac{A \cdot r^2 \cdot \pi}{m_{Pd}}}{\frac{m_{Pd}}{g_{SiO2}} \cdot D \cdot m_W}$$

*Attention*: CO adsorbs in linear and bridged form on Pd atoms. (Equilibrium between linear and bridged CO depends on the partial pressure of CO.)

M.A. Vannice, S.Y. Wang, The Journal of Physical Chemistry 85 (1981) 2543-2546.<sup>5</sup>

 $\epsilon_{l} = 3.3 \cdot 10^{7} \text{ cm mol}^{-1}$   $\epsilon_{b} = 85 \cdot 10^{7} \text{ cm mol}^{-1}$ 

*Calculation of*  $\varepsilon_l$  *and*  $\varepsilon_b$  (assuming  $\frac{\varepsilon_b}{\varepsilon_l} = \frac{85}{3.3}^5$ )

$$\frac{\varepsilon_{b}}{\varepsilon_{l}} = \frac{85}{3.3} \qquad \qquad \varepsilon_{b} = \frac{85}{3.3} \cdot \varepsilon_{l}$$

 $n_{S} = n_{l} + 2 \cdot n_{b} \qquad \qquad n_{b} = \frac{n_{S} - n_{l}}{2}$ 

 $n_l$  = Number of linearly adsorbed CO on Pd [mol]

n<sub>b</sub> = Number of bridged adsorbed CO on Pd [mol]

$$n_{l} = \frac{A_{l} \cdot S}{\varepsilon_{l}} \qquad \qquad n_{b} = \frac{A_{b} \cdot S}{\varepsilon_{b}}$$

$$n_{S} = \frac{A_{I} \cdot s}{\varepsilon_{I}} + 2 \cdot \frac{A_{b} \cdot s}{\varepsilon_{b}} = \frac{A_{I} \cdot s}{\varepsilon_{I}} + 2 \cdot \frac{A_{b} \cdot s}{\varepsilon_{I} \cdot \frac{85}{3.3}}$$

$$\mathbf{n}_{S} = \frac{\left(\frac{85}{3.3} \cdot \mathbf{A}_{l} + 2 \cdot \mathbf{A}_{b}\right)S}{\varepsilon_{l} \cdot \frac{85}{3.3}}$$

$$n_{S} = \frac{\frac{m_{Pd}}{g_{SiO2}}}{M_{Pd}} \cdot D \cdot m_{W} = \frac{\frac{0.025 \text{ g}_{Pd}}{g_{SiO2}}}{\frac{106.4 \frac{g}{mol}}{mol}} \cdot 0.14 \cdot 0.01072 \text{ g} = 3.526 \cdot 10^{-7} \text{mol}$$

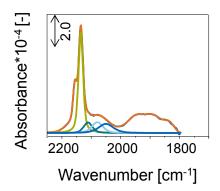
$$\varepsilon_{l,Pd} = \frac{\left(\frac{85}{3.3} \cdot A_l + 2 \cdot A_b\right) r^2 \pi}{n_S \cdot \frac{85}{3.3}}$$

$$\varepsilon_{l,Pd} = \frac{(\frac{85}{3.3} \cdot 2.562 \text{ cm}^{-1} + 2 \cdot 8.27 \text{ cm}^{-1})(0.6 \text{ cm})^2 \pi}{\frac{85}{3.3} \cdot 3.526 \cdot 10^{-7} \text{ mol}}$$

$$\varepsilon_{l,Pd} = 1.03 \cdot 10^7 \text{ cm mol}^{-1}$$
$$\varepsilon_{b,Pd} = \frac{85}{3.3} \cdot \varepsilon_{l,Pd}$$
$$\varepsilon_{b,Pd} = 2.65 \cdot 10^8 \text{ cm mol}^{-1}$$
$$\frac{\varepsilon_{l,Au}}{\varepsilon_{l,Pd}} = \frac{1.40}{1.03} = 1.36$$

# IR Spectroscopy of Adsorbed CO on Unwashed PdAu/SiO<sub>2</sub> after Reaction

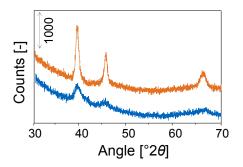
As seen in Figure S4, the bright green band for CO linearly adsorbed on "Au next to Pd" dominated the spectrum compared to CO on "Au next to Au" (dark green), "Pd next to Pd" (bright blue) and "Pd next to Au" (blue). The lower Pd/Au ratio of 0.62 on unwashed compared to washed PdAu/SiO<sub>2</sub> after reaction of 0.83 indicated that he washing procedure leads to a slight overestimation of the Pd surface concentration, which is more pronounced on Au enriched PdAu particles.



**Figure S4.** IR spectrum of 1.0 mbar CO adsorbed on spent, unwashed PdAu/SiO<sub>2</sub>. Green lines represent CO on Au and blue lines CO on Pd at -150 °C.

#### X-Ray Diffraction on KOAc Free and KOAcP Pd(OAc)<sub>2</sub>/SiO<sub>2</sub> after reaction

In order to estimate the reduction behavior of the reactive  $Pd_3(OAc)_6$  and  $K_2Pd_2(OAc)_6$ intermediates, two model catalysts,  $Pd(OAc)_2/SO_2$  (Figure S5, blue) and  $Pd(OAc)_2/KOAc/SiO_2$  (Figure S5, orange) were studied by XRD after reaction. The general lower values for the full width at half maximum and the narrower Pd reflections revealed the formation of bigger Pd particles on  $Pd(OAc)_2/KOAc/SiO_2$ . We associate the bigger Pd particles to a lower reduction stability of  $K_2Pd_2(OAc)_6$  compared to  $Pd_3(OAc)_6$ .



**Figure S5.** X-ray profile between 30 - 70 °2 $\theta$  of Pd(OAc)<sub>2</sub>/SO<sub>2</sub> (blue) and Pd(OAc)<sub>2</sub>/KOAc/SiO<sub>2</sub> (orange) after reaction.

#### REFERENCES

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